

MAY 11 2006

TO THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 10/733,201
Filing Date [December 9, 2003
Inventor Garo J. Derderian et al.
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner Unknown
Attorney Docket No. MI22-2402
Customer No. 021567
Title ... Atomic Layer Deposition Method of Depositing an Oxide on a Substrate

TO: Commissioner for Patents
P. O. Box 1450
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